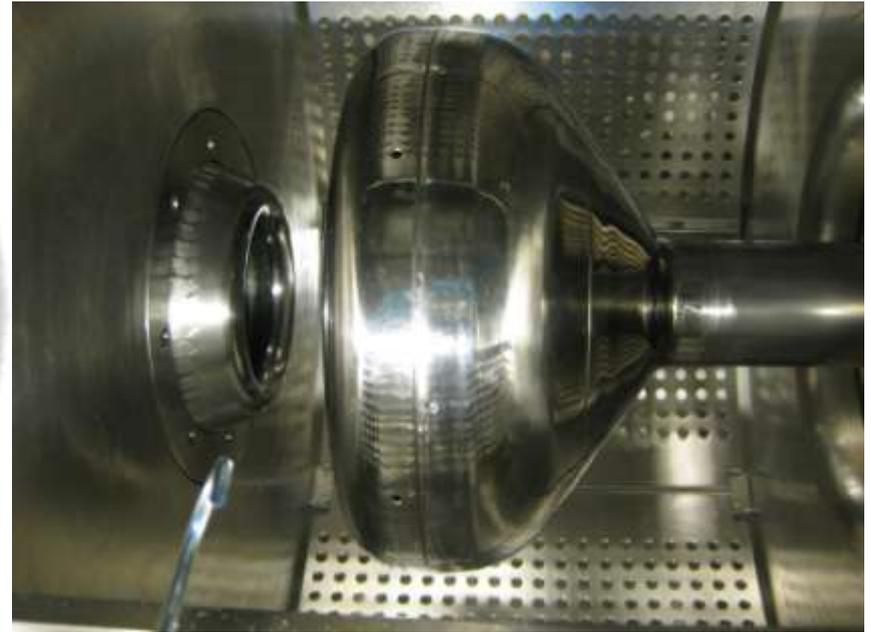
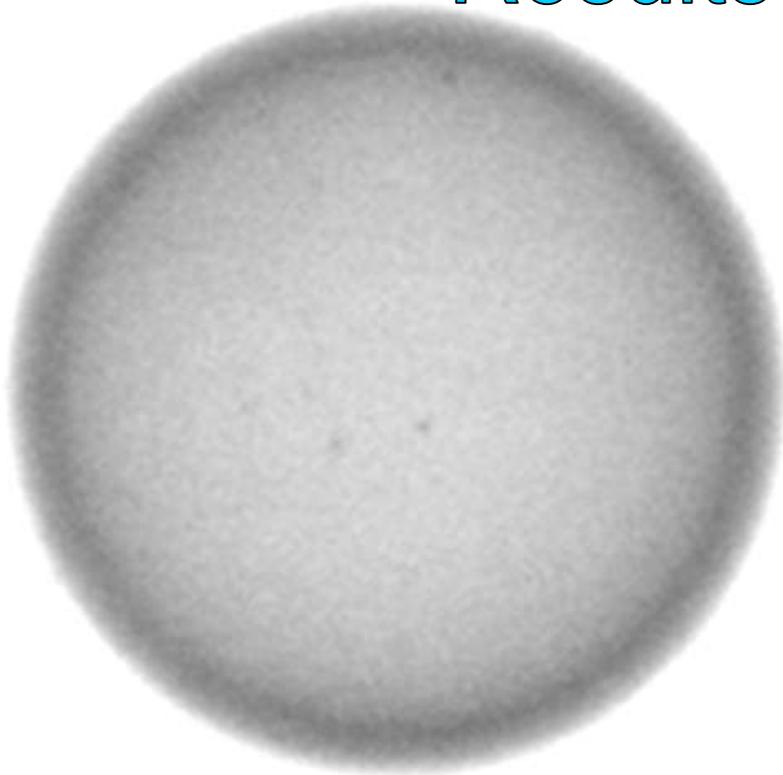


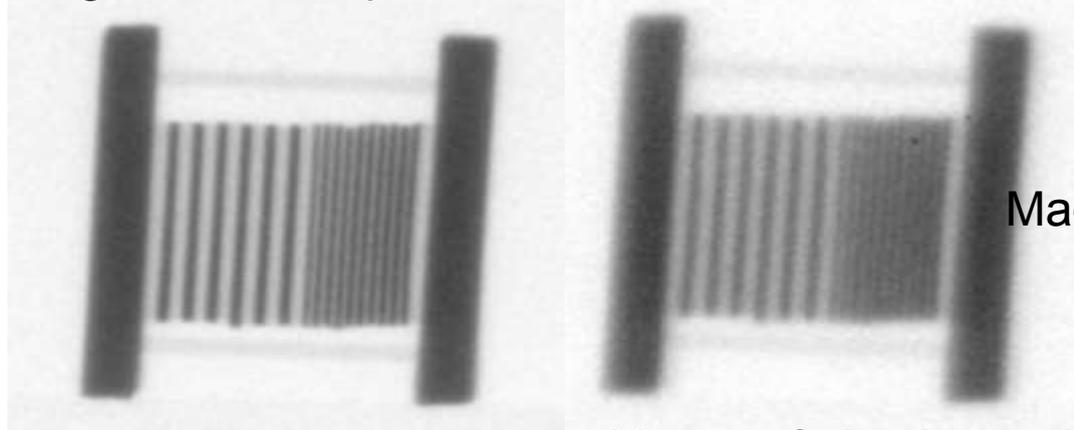
Results of LIA-2 operation.



Logachev Pavel, BINP, Novosibirsk.

RuPAC 2014, Obninsk, 6-10 October 2014.

Tungsten sheets phantom with 1.0 and 0.5 mm step.



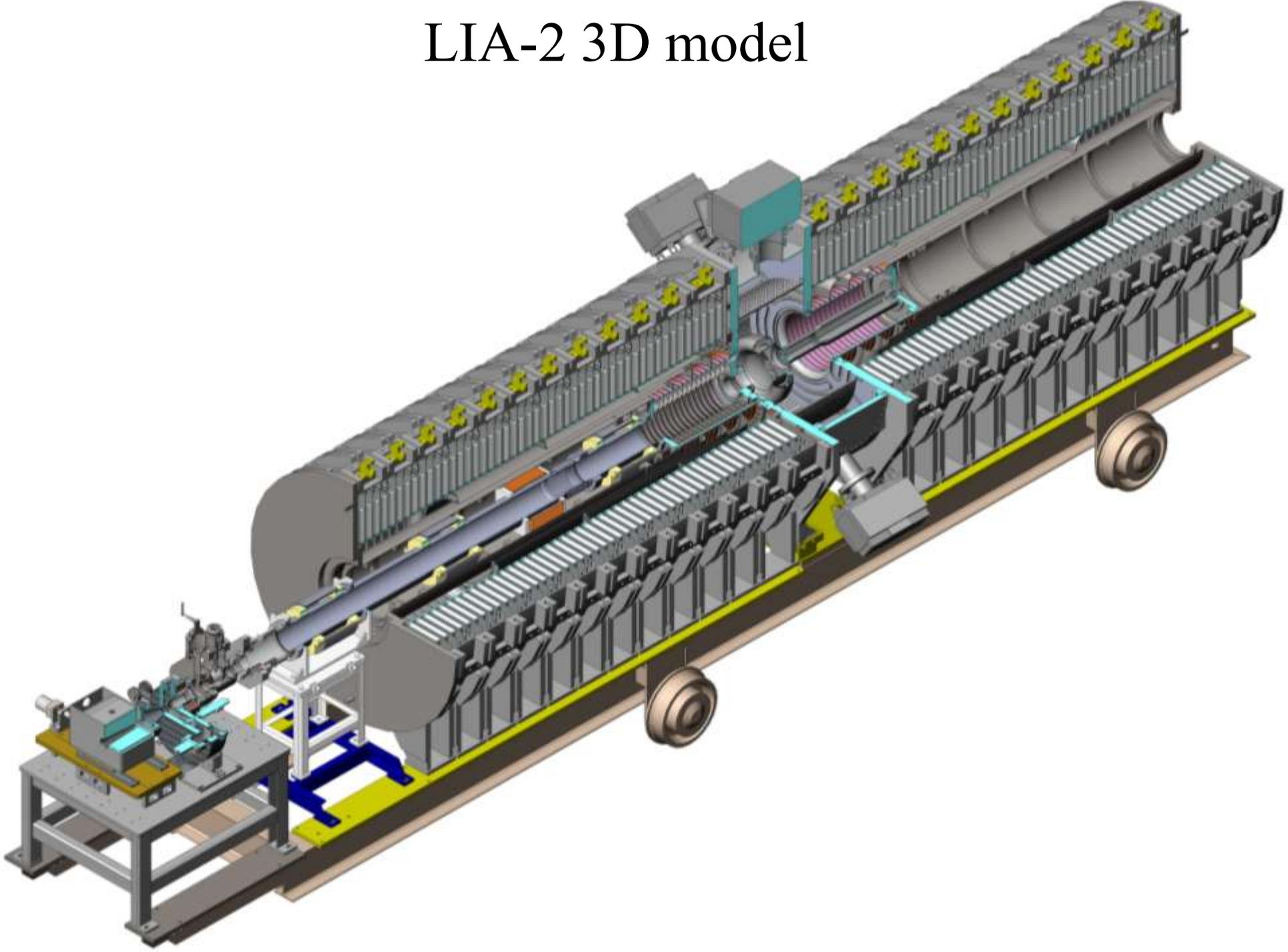
LIA-2 pictures:

Magnification factor = 1.3

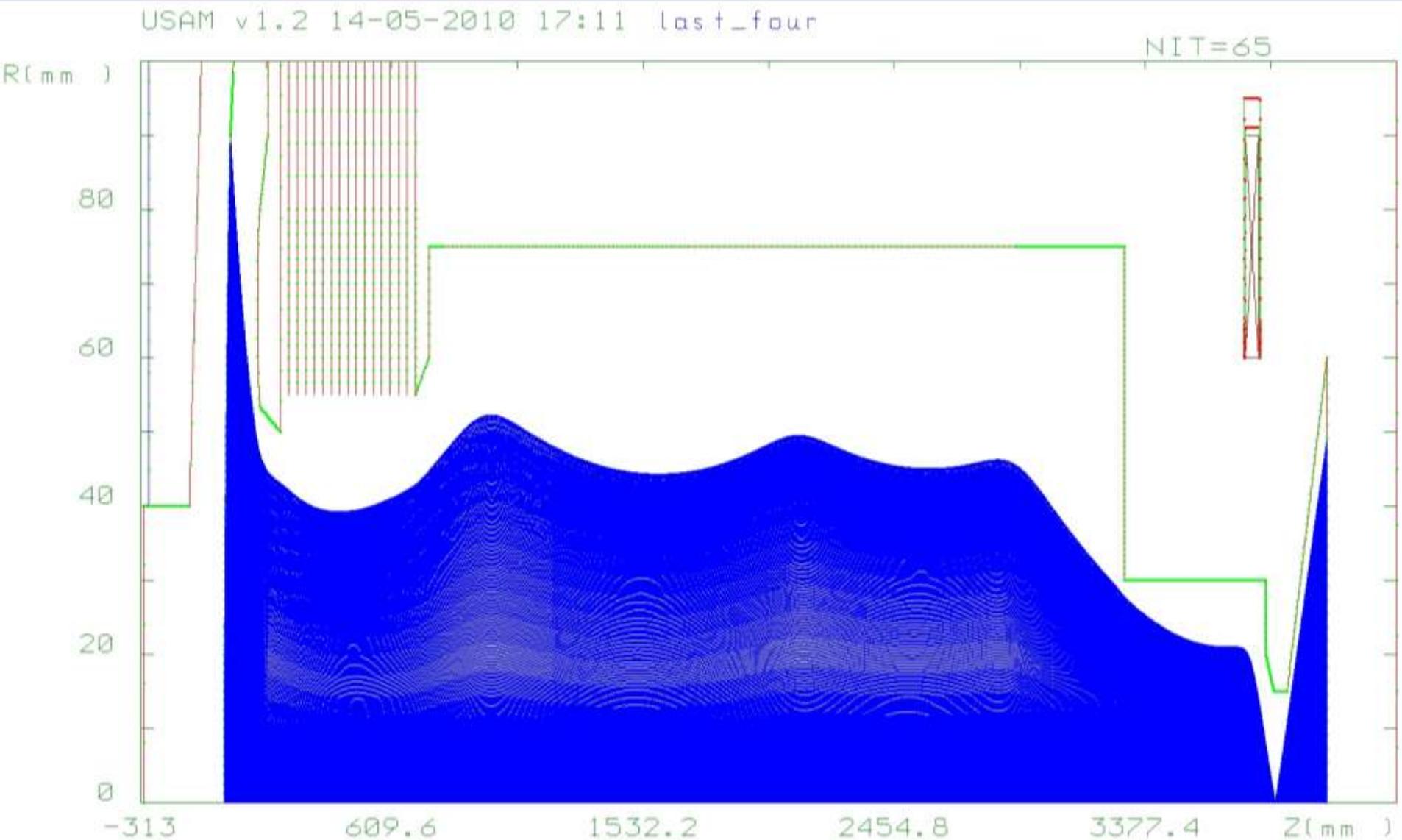
+ 20 mm of aluminum shockwave shielding

Parameter (Units)	Value
Maximum electron beam energy (MeV)	2.0
Maximum electron beam current (kA)	2.0
Number of pulses in the burst	2
Cathode heater DC power (kW)	2.5
Time interval between pulses in the burst (μs)	2 - 30
Pulse duration, flat top 4% (ns)	200
Maximum repetition rate (Hz)	0.1
Min. beam spot size FWHM on the target (mm)	0.7

LIA-2 3D model



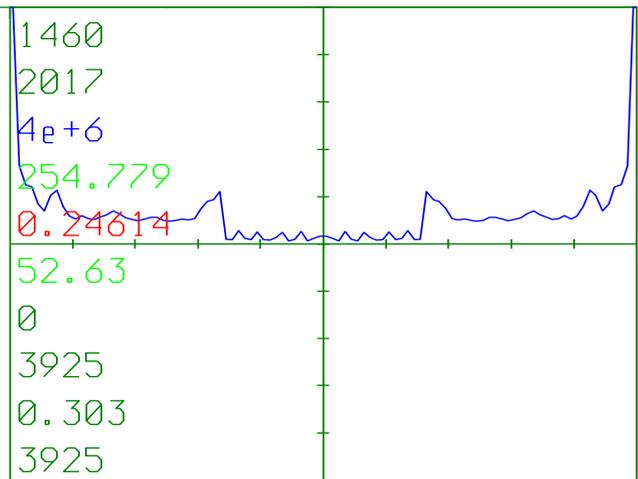
Electron beam envelope at 2 MeV, 2 kA from cathode up to beam dump.



R(mm)

Electron beam structure near the target

Wmin(keV)=	1460
I(A)=	2017
JM(A/cm**2)=	4e+6
ALFA(MRAD)=	254.779
VTMAX/UZ=	0.24614
EPS(MRAD*mm)=	52.63
R1(mm)=	0
Z1(mm)=	3925
R2(mm)=	0.303
Z2(mm)=	3925



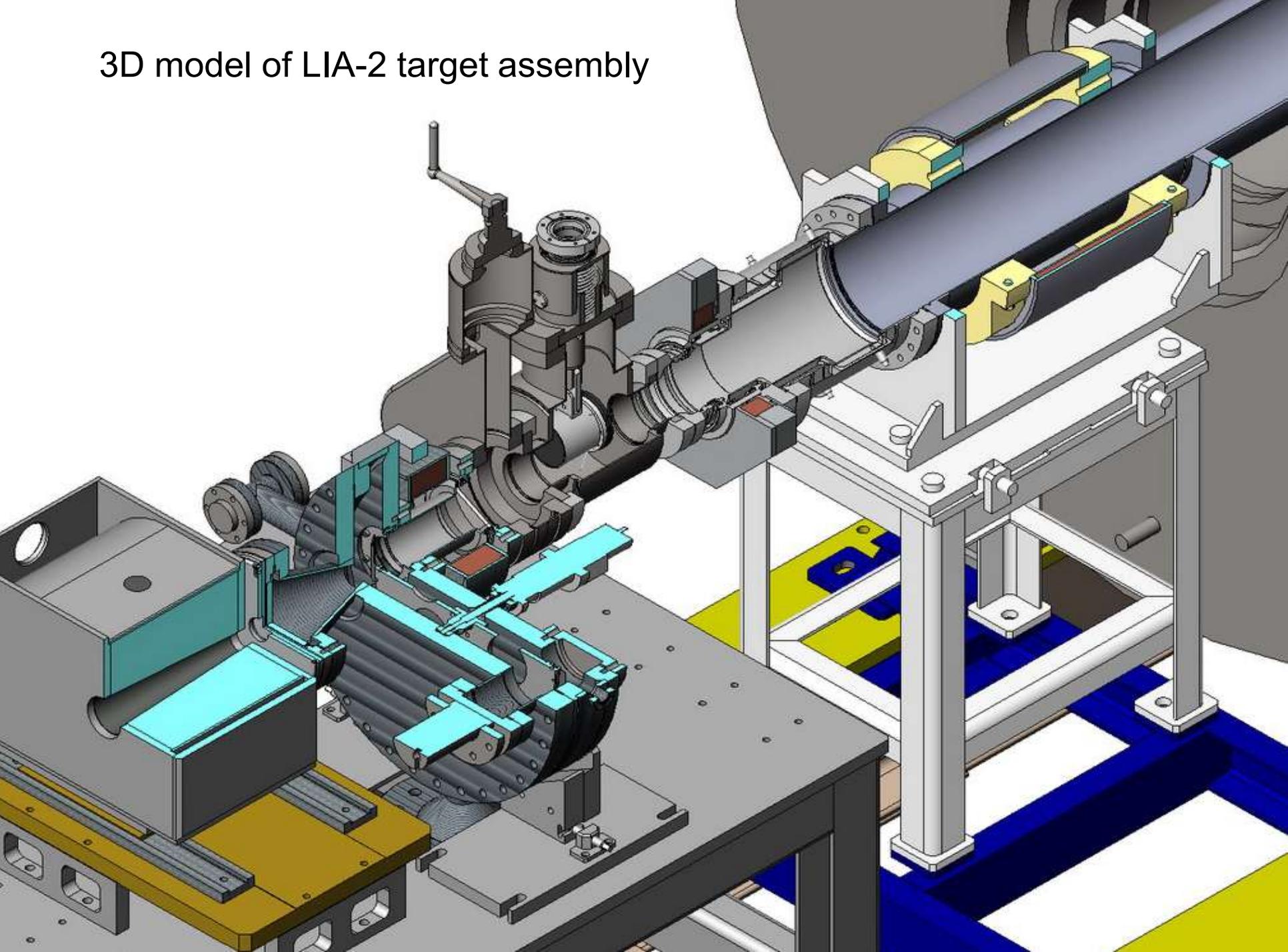
8
6
4
2
0

Ta Target



3900 3910 3920 3930 3940 Z(mm)

3D model of LIA-2 target assembly



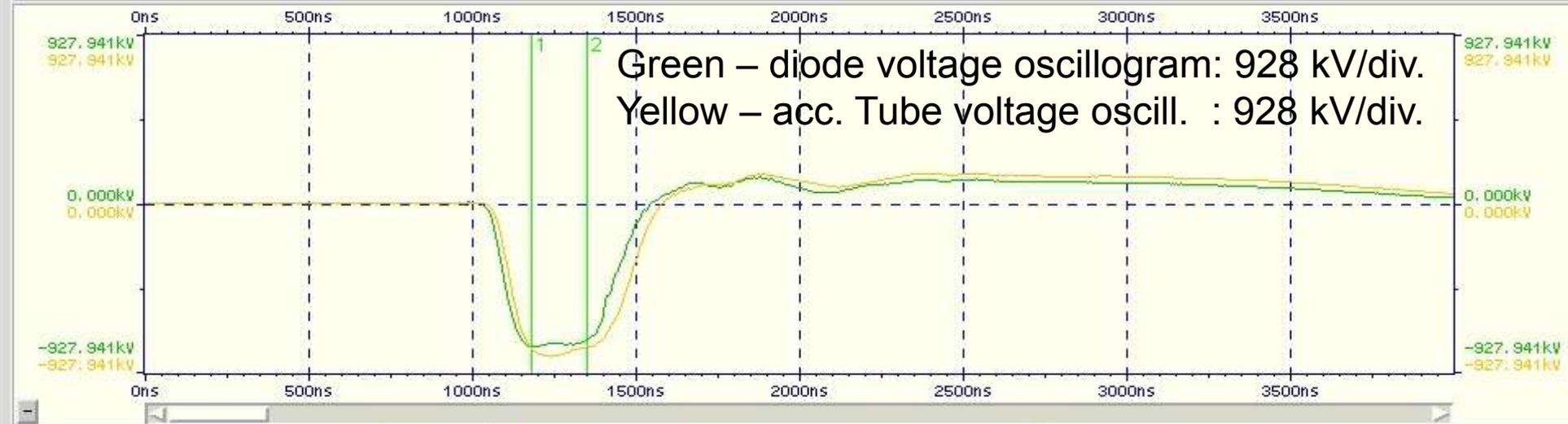


Target explosion due to electron beam energy deposition generates tantalum drops with very high velocity (up to few km/s). These drops damage the emission ability of the cathode and reduce the electric breakdown strength of diode and further accelerating tube electrodes. This is why LIA-2 can reliably operate 2 MeV, 2 kA without target explosion and only 1.6 MeV, 1.5 kA with target explosion.

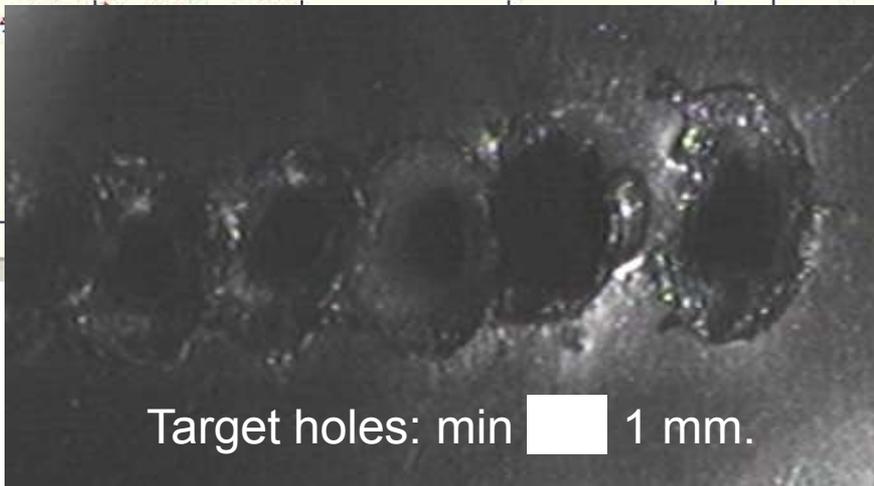
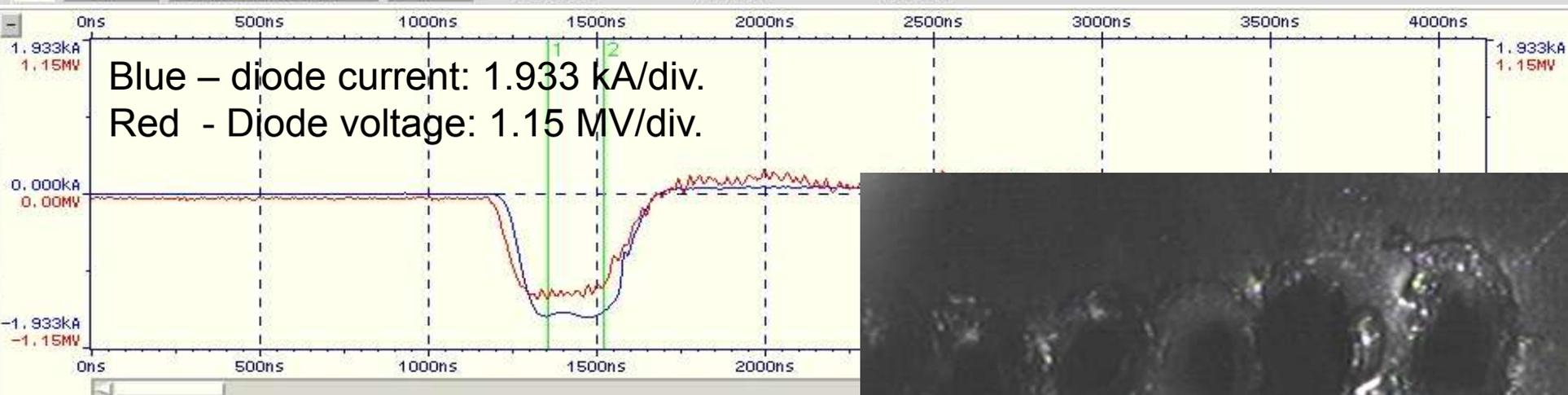
A close-up photograph looking through a circular anode aperture. The central area is a bright, circular spot of light, representing the tantalum drops flux. The surrounding area is dark, and the metal surfaces of the aperture and cathode are visible.

Tantalum drops on the cathode surface.
View through the anode aperture.

The Ta drops flux is collimated near the target
as maximum as it possible in order to keep electron
beam uncollimated.

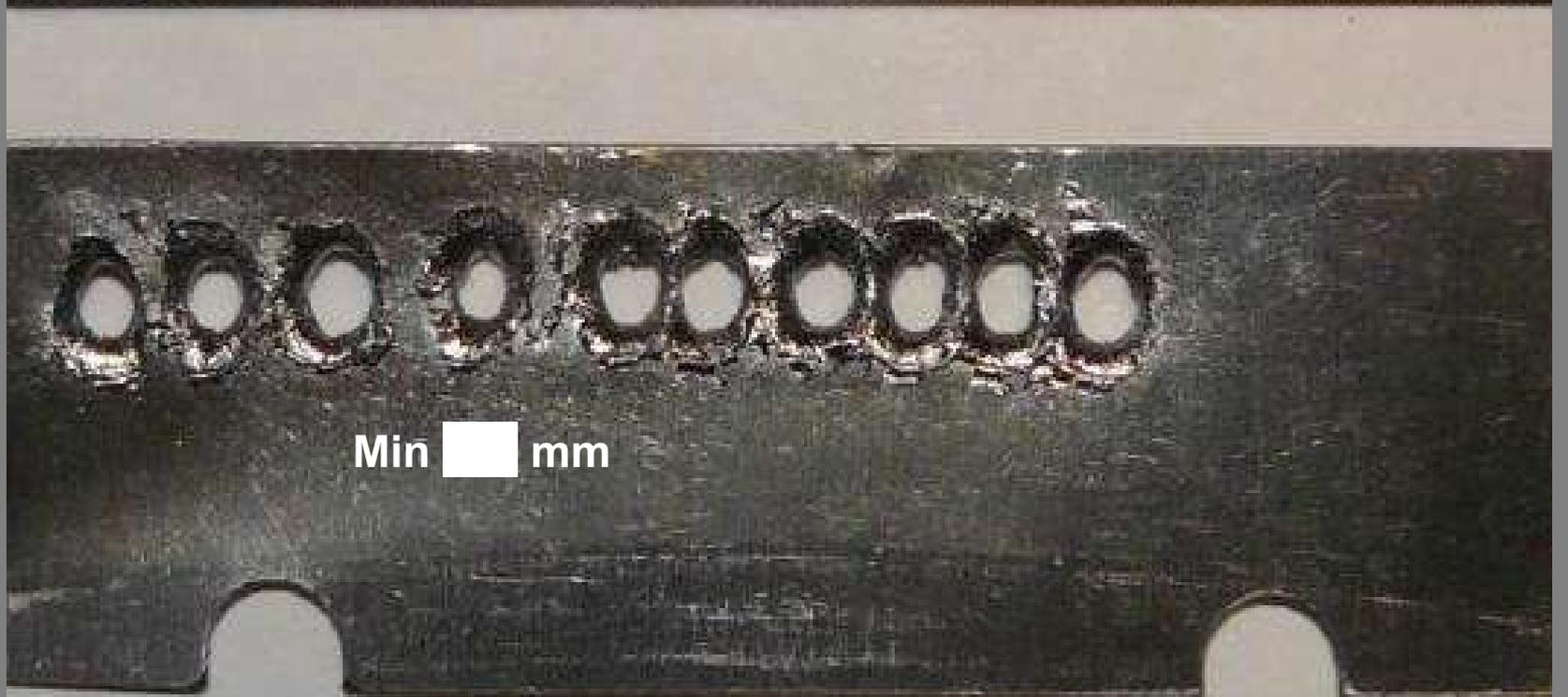


1	x4	U все 1-ro MeV	1-A				lavg@Trp1	-1.50kA
2	x4	U все 2-ro MeV	1-A				Uavg@1stMeV	-774.56kV
3	x4	U sum 1-ro MeV	1-A	-790.426	-749.647	40.779	МикроПервеанс	2.20
4	x4	U sum 2-ro MeV	1-A	-802.282	-791.332	10.950		

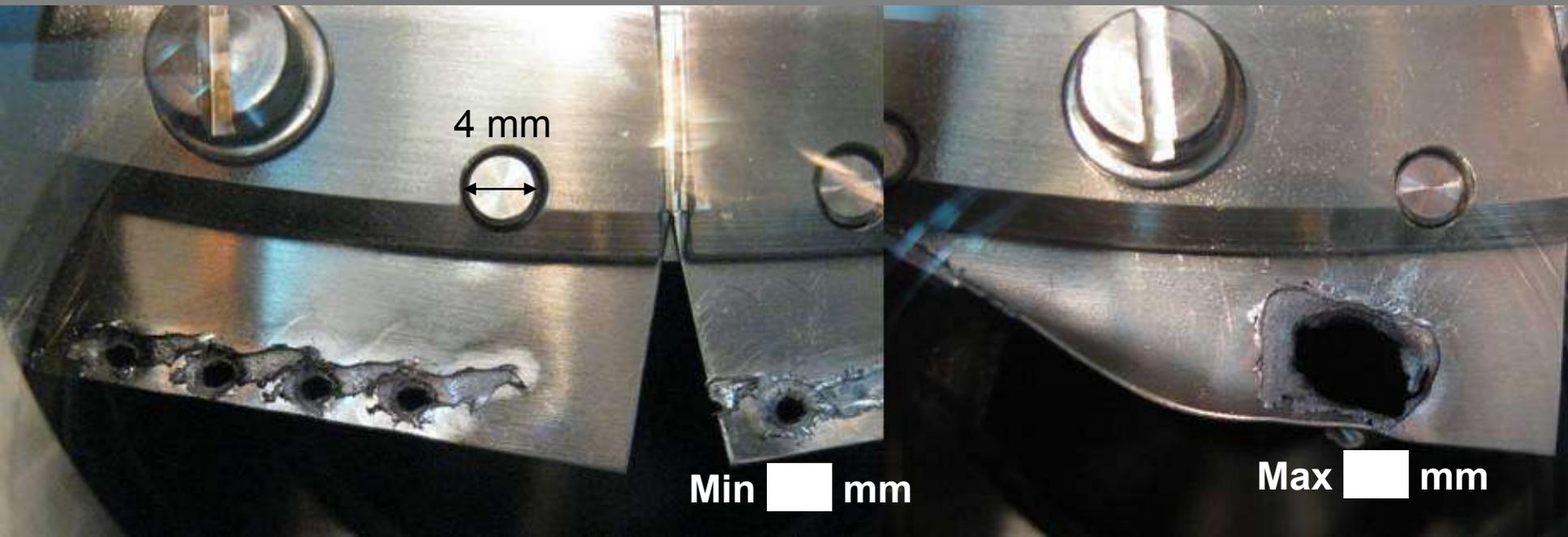


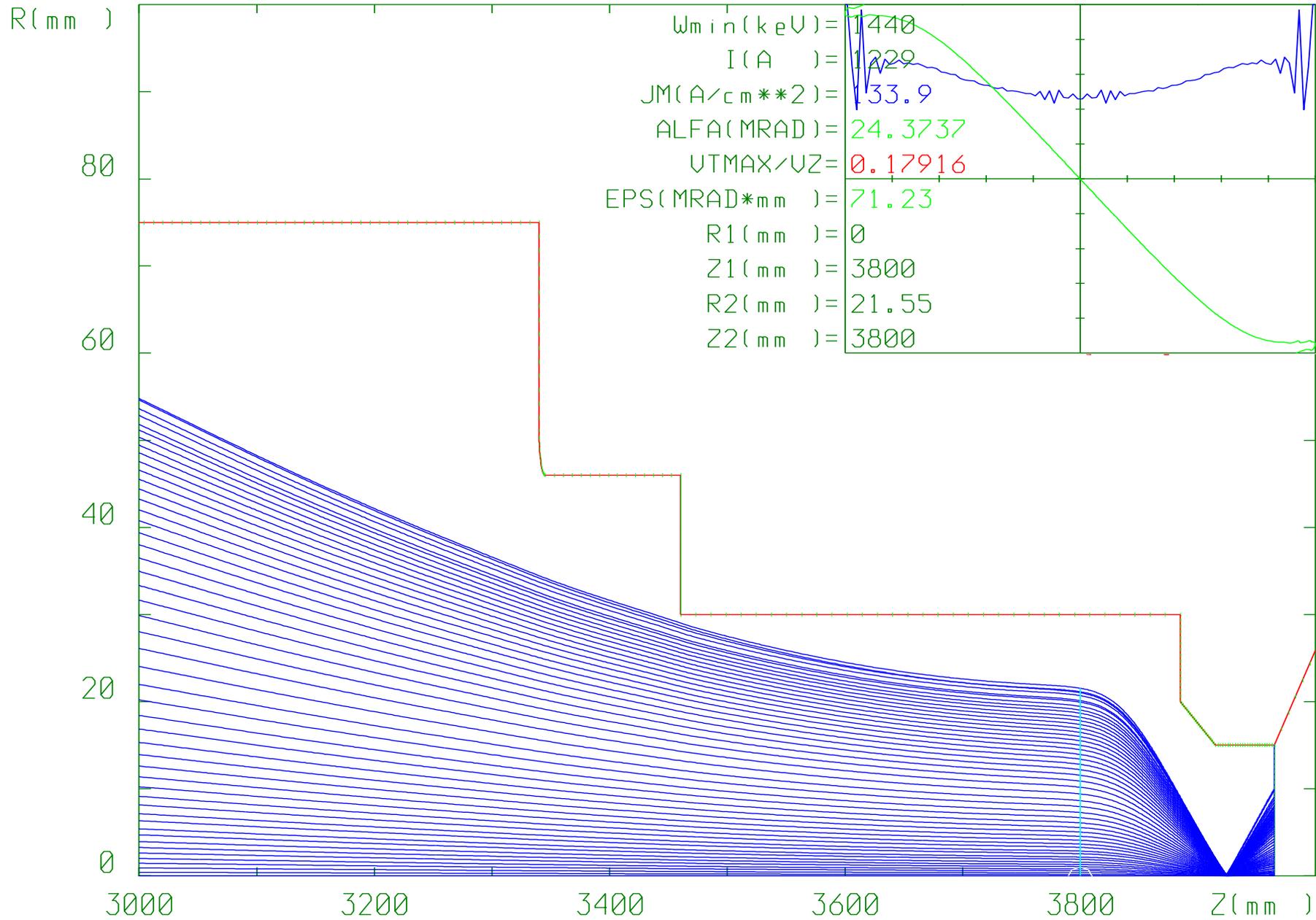
Reliable operation regime with target explosion

Target holes: min 1 mm.



For fixed beam energy and current the hole diameter in the target can be changed by final lens strength regulation (from minimum possible to maximum possible value).
These two values help to perform the beam emittance estimation.





For Gaussian transverse distribution of power dissipation in the target:

$$\xi = \xi_0 e^{-\frac{r^2}{2\sigma^2}} \quad Q_0 = \int \pi \sigma_r^2 \xi \quad \xi_0 = \xi_{max} e^{\frac{r_e^2}{2\sigma^2}} = \text{const}$$

$$\xi_{max} = \frac{Q_0}{\pi^2 \sigma_{max}^2}$$

$$r_{FWHM} = \sqrt{2 \ln 2} \sigma$$

$$r_e = 0.5 \text{ mm}$$

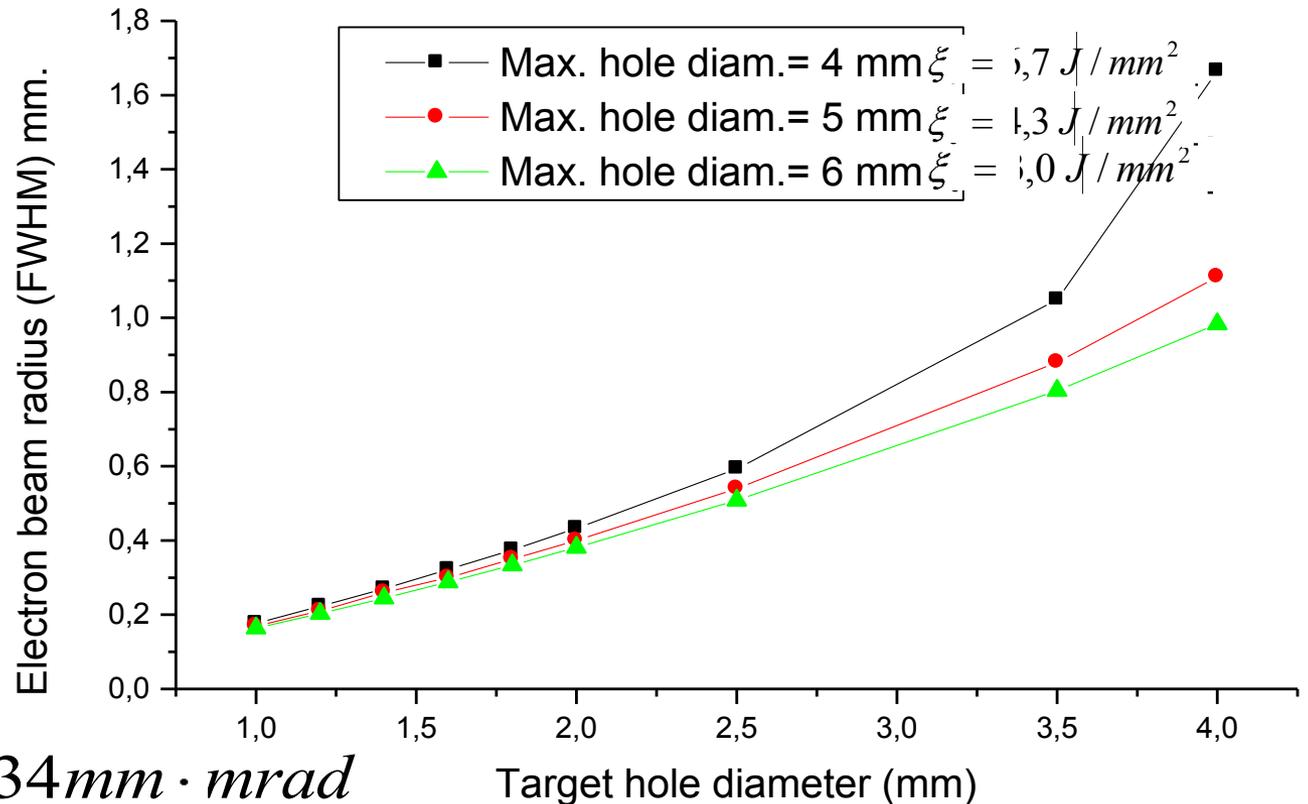
$$r_{FWHM} = 0.17 \text{ mm}$$

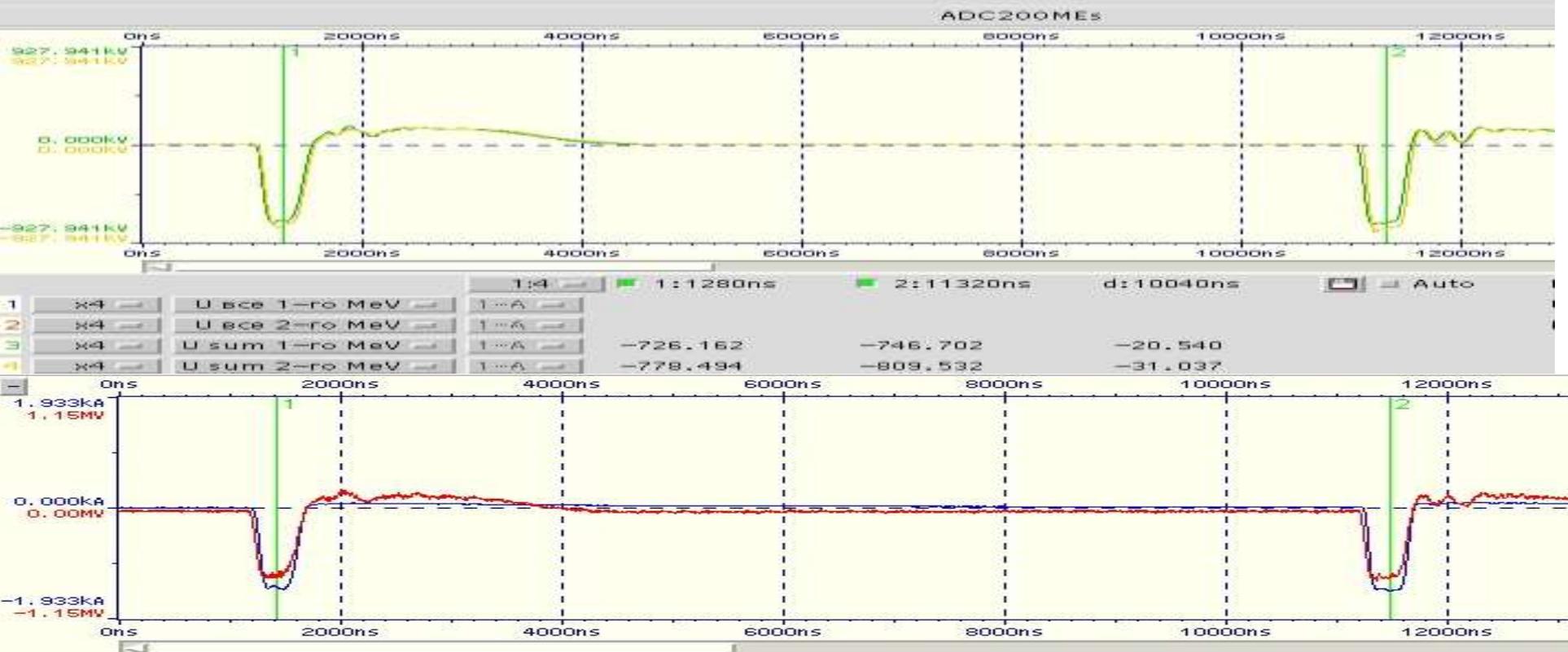
$$\alpha_{target} = 100 \text{ mrad}$$

$$\varepsilon = \alpha_{target} \cdot r_{FWHM} = 34 \text{ mm} \cdot \text{mrad}$$

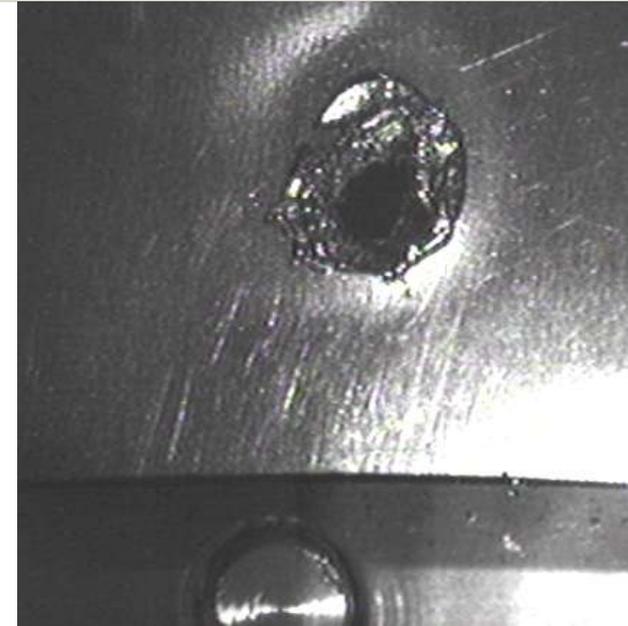
(1.6 MeV, 1.5 kA, 200 ns, 0.5 mm Ta target)

$$Q_0 = 130 \text{ J}$$





Two pulse operation of LIA-2, 1 mm thick Ta target.
 1.6 MeV, 1.5 kA.
 10 μ s between pulses.
 Normalized beam emittance: $110 \pi \text{ mm}\cdot\text{mrad}$.



Results

- Max reliable regime with target explosion: 1.6 MV, 1.5 kA.
- Max reliable regime without target explosion: 2.0 MV, 2.0 kA.
- Minimum normalized beam emittance:
110 $\pi \cdot \text{mm} \cdot \text{mrad}$
- Two pulse operation: OK on 1 mm Ta target with the same normalized emittance.



Thank you for your attention

Results of LIA-2 radiographic application have been presented yesterday at the poster session «B» № 51.